

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination BOJKOV ET AL.	
		Examiner Monica Lewis	Art Unit 2822	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-2003/0013291	01-2003	Chen et al.	438/613
	C	US-			
	D	US-			
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	F	US-			
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	I	US-			
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Peter Van Zant, Microchip Fabrication, 2000, McGraw-Hill, 115-129.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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